



PATENT APPLICATION

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q78681

Takayasu YAMAMOTO, et al.

Appln. No.: 10/721,381

Group Art Unit: 2877

Confirmation No.: 6006

Examiner: Sang H. NGUYEN

Filed: November 26, 2003

For: INSPECTING DEVICE FOR SEMICONDUCTOR WAFER

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 17, 2004, please amend the above-identified application as follows on the accompanying pages.

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